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APPLICANTS

Steffen F. Schulze, Sherwood, OR;  
 Enio L. Carpi, Round Rock, TX;

\*\* CONTINUING DATA \*\*\*\*\*  
 NONE *IR*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
 NONE *IR*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 04/19/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY OR	SHEETS DRAWING 3	TOTAL CLAIMS 48	INDEPENDENT CLAIMS 5
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Verified and Acknowledged  
 Examiner's Signature \_\_\_\_\_ Initials *IR*

ADDRESS  
 48154  
 SLATER & MATSIL LLP  
 17950 PRESTON ROAD  
 SUITE 1000  
 DALLAS, TX  
 75252

TITLE  
 Method for the repair of defects in photolithographic masks for patterning semiconductor wafers

FILING FEE  RECEIVED 1576	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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